Synthesis and Structural Characterisation of Compounds with Gallium-Silicon and Indium-Silicon Bonds

Atta M. Arif, Alan H. Cowley,* Tammy M. Elkins, and Richard A. Jones*

Department of Chemistry, The University of Texas at Austin, Austin, Texas 78712, U.S.A.

The compounds $[\{(Me_3Si)_3Si\}_2M(\mu-Cl)_2Li(thf)_2]$ (M = Ga or In; thf = tetrahydrofuran) have been prepared and the structures of both compounds have been determined by X-ray crystallography.

The use of indium and gallium compounds in the electronics industry has stimulated interest in the chemistry of these elements. In this context, the recent reports of novel tris(trimethylsilyl)methyl indium compounds by Eaborn, Smith et al.¹ prompt us to report comparable developments with the analogous tris(trimethylsilyl)silyl ligand. Previous examples of gallium-silicon and indium-silicon compounds appear to be confined to $(Me_3Si)_3M$, $M = Ga^2$ or $In,^3$ and $Li[Ga(SiMe_3)_4].^2$ However, no structural data are available for these heat-, light-, and oxygen-sensitive compounds.† Recognising the kinetic stabilisation afforded by bulky groups, it seemed reasonable to explore the implications of replacing the Me_3Si by the $(Me_3Si)_3Si$ ligand. In passing, we note that organometallic complexes featuring the latter ligand are rather rare.⁴

Treatment of MCl₃ (M = Ga or In) with three equivalents of Li[Si(SiMe₃)₃]·3thf⁵ (thf = tetrahydrofuran) in Et₂O solution at $-78\,^{\circ}$ C, followed by slow warming to room temperature, resulted in cream coloured solutions and a white precipitate. Evaporation of the Et₂O, re-dissolution of the residues in n-hexane, and filtration produced pale yellow solutions. X-Ray-quality crystals of [{(Me₃Si)₃Si}₂M(μ -Cl)₂Li(thf)₂], M = Ga, (1); M = In, (2), formed upon cooling saturated n-hexane solutions to $-20\,^{\circ}$ C. Both compounds are thermally stable but somewhat air-sensitive.

Compounds (1) and (2) can be regarded as a doublechloride bridged complex of [(Me₃Si)₃Si]₂MCl and solvated LiCl (Figure 1).‡ The Si, Li, and M atoms adopt tetrahedral geometries, albeit with varying degrees of distortion. Thus, the Si(1)-M-Si(5) angles of 138.0(2)° (M = Ga) and 139.9(2)° (M = In) are unusually wide, presumably owing to steric interactions. Likewise, the average Si-Si-Si angle is ~2° less than the average M-Si-Si angle in both molecules. To the best of our knowledge, gallium-silicon and indium-silicon bond lengths have not been reported previously. However, our average Ga-Si and In-Si bond lengths of 2.439(5) and 2.591(7) Å, respectively, are somewhat larger than the sums of covalent radii (Ga-Si = 2.37; In-Si = 2.55 Å). Mention

‡ Crystal data for (1): $C_{26}H_{70}Cl_2GaLiO_2Si_8$, M = 787.10, monoclinic, space group $P2_1/c$ (No. 14), a = 13.754(3), b = 17.180(3), c =20.813(4) Å, $\beta = 104.25(2)^{\circ}$, U = 4767 Å³, Z = 4, $D_c = 1.097$ g cm⁻³, $\mu(\text{Mo-}K_{\alpha}) = 9.05 \text{ cm}^{-1}$; crystal data for (2): $C_{26}H_{70}Cl_2InLiO_2Si_8$, M =832.21, monoclinic, space group $P2_1/c$ (No. 14), a=13.817(3), b=17.315(3), c=20.953(3) Å, $\beta=105.12(1)^\circ$, U=4839 Å³, Z=4, $D_c=105.12(1)^\circ$, U=4830 Å³, $U=40.12(1)^\circ$, $U=40.12(1)^\circ$, U1.203 g cm⁻³, $\mu(\text{Mo-}K_{\alpha}) = 15.68 \text{ cm}^{-1}$. Totals of 7686 and 6713 unique reflections were measured on an Enraf-Nonius CAD-4 diffractometer over the range $3.0 \le 2\theta \le 46^{\circ}$ ($\theta/2\theta$ scan mode) for (1) and (2) respectively. The data were corrected for Lorentz, polarisation, and decay effects. Empirical absorption corrections were also applied to (1) and (2). Both structures were solved by direct methods and refined (difference Fourier, full-matrix, least-squares) using 1625 and 2542 reflections with $I > 3.0\sigma(I)$ for (1) and (2) respectively. The final residuals were R = 0.0830 and $R_w = 0.0930$ for (1) and R =0.0738 and $R_{\rm w} = 0.0820$ for (2). Atomic co-ordinates, bond lengths and angles, and thermal parameters have been deposited at the Cambridge Crystallographic Data Centre. See Notice to Authors, Issue No. 1, 1986.

^{† (}Me₃Si)₃In is also light-sensitive.³

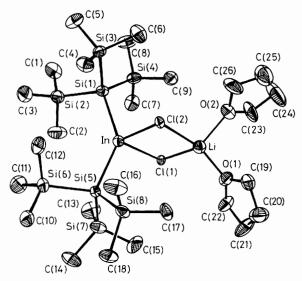


Figure 1. View (ORTEP) of $[\{(Me_3Si)_3Si\}_2In(\mu\text{-Cl})_2Li(thf)_2]$ (2), showing the atom numbering scheme. Important bond lengths (Å) and angles (°) are as follows [the corresponding values for (1) are given in brackets]: In–Si(1) 2.591(7) [2.443(5)], In–Si(5) 2.605(7) [2.435(5)], Si(1)–Si(2) 2.353(11) [2.334(8)], Si(1)–Si(3) 2.365(10) [2.389(7)], Si(1)–Si(4) 2.346(10) [2.338(7)], Si(5)–Si(6) 2.334(9) [2.360(7)], Si(5)–Si(7) 2.360(10) [2.356(8)], Si(5)–Si(8) 2.337(10) [2.334(7)], Si(1)–In–Si(5) 139.9(2) [138.0(2)], Cl(1)–In–Cl(2) 90.6(1) [93.75(9)].

should be made of the fact that the chlorine atom positions of both molecules are disordered owing to the presence of $\sim 17\%$ of bromine. In turn, the incorporation of bromine into (1) and (2) stems from the use of a MeLi-LiBr complex in the

preparation of Li[Si(SiMe₃)₃]·3thf.^{5a} The presence of bromine was corroborated by the 70 eV electron impact mass spectra of (1) and (2) which exhibit peaks corresponding to Me loss from [(Me₃Si)₃Si]₂MCl and [(Me₃Si)₃Si]₂MBr.

Finally, attempts were made to prepare $(Me_3Si)_3SiIn$ by treatment of InCl with Li[Si(SiMe₃)₃]·3thf. However, only (2) was isolated owing presumably to the disproportionation $3InCl \rightarrow 2In + InCl_3$.

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